

L Number	Hits	Search Text	DB	Time stamp
-	287	conductor same ceramic same nitride	EPO; JPO; DERWENT; IBM TDB	2003/02/27 14:10
-	3	(conductor same ceramic same nitride) and wafer and probe	EPO; JPO; DERWENT; IBM TDB	2003/02/25 16:14
-	0	2001223249.URPN.	USPAT	2003/02/25 16:15
-	0	2001223249.URPN.	USPAT	2003/02/25 16:15
-	0	2001203245.URPN.	USPAT	2003/02/25 16:15
-	0	2001148405.URPN.	USPAT	2003/02/25 16:15
-	1	2002-208782.NRAN.	DERWENT	2003/02/25 16:15
-	1	2002-271649.NRAN.	DERWENT	2003/02/25 16:15
-	0	2001223249.URPN.	USPAT	2003/02/25 16:16
-	17	conductor same ceramic same nitride and wafer	EPO; JPO; DERWENT; IBM TDB	2003/02/25 16:54
-	1	2002-321836.NRAN.	DERWENT	2003/02/25 16:35
-	0	2001206772.URPN.	USPAT	2003/02/25 16:51
-	0	2001206772.URPN.	USPAT	2003/02/25 16:51
-	1	2002-283782.NRAN.	DERWENT	2003/02/25 16:51
-	1	("6475606").PN.	USPAT; US-PGPUB	2003/02/25 16:54
-	4	peltier same wafer same prob\$	USPAT; US-PGPUB	2003/02/27 12:00
-	199	peltier same wafer	USPAT; US-PGPUB	2003/02/27 12:01
-	35	peltier near device same wafer	USPAT; US-PGPUB	2003/02/27 12:01
-	7	("3067310"   "4034207"   "4443691"   "5068517"   "5072236"   "6080970"   "6133557").PN.	USPAT	2003/02/27 12:32
-	1	("6475606").PN.	USPAT; US-PGPUB	2003/02/27 13:44
-	1	("6215545").PN.	USPAT; US-PGPUB	2003/02/27 14:11
-	1	("5231291").PN.	USPAT; US-PGPUB	2003/02/27 14:11
-	1	("5220171").PN.	USPAT; US-PGPUB	2003/02/27 14:12
-	1	("4385434").PN.	USPAT; US-PGPUB	2003/02/27 14:17
-	233	peltier adj device	EPO; JPO; DERWENT; IBM TDB	2003/02/27 14:18
-	3	peltier adj device and wafer	EPO; JPO; DERWENT; IBM TDB	2003/02/27 14:18
-	26	peltier adj device	USOCR	2003/02/27 14:21
-	18	peltier adj device and (wafer semiconductor)	USOCR	2003/02/27 14:22
-	4	peltier adj device and wafer	USOCR	2003/02/27 14:22